Source test of the 180 nm chip with GLAST and CMS sensors

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Contents

- Presentation of the hardware in the Paris Lab test bench
- Test of a 180 nm UMC preamp shaper, using a Sr90 source
- Some preliminary results
 - Conclusion and outlook



Presentation of the hardware in the Paris Lab test bench

There where 3 kinds of detectors:

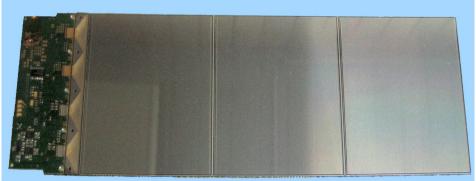
- One CMS detector with 3 modules fully equipped with 4 VA1 from IDEAS™
- One another CMS detector with 3 modules equipped with 2 VA1 and 4 180 nm UMC
- One GLAST detector with 10 modules equipped with
 2 VA1 and 4 180 nm UMC

Sensors





without electronics
90 cm strip long
228 um pitch, 500 um thick



CMS detector 3 sensors

fully equipped

28 cm strip long

183 um pitch, 410 um thick

4 VA1 readout card

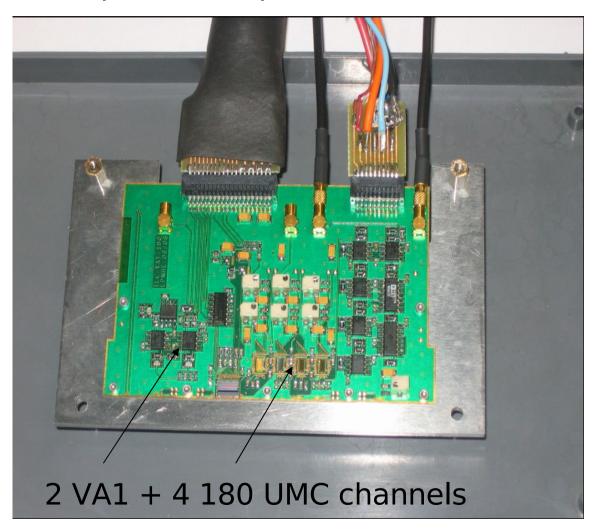
with pitch adapter

Hardware and Software in the Paris test bench

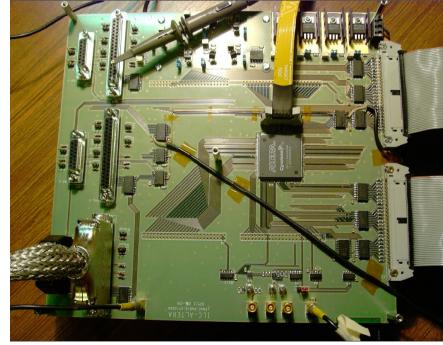
- Some low voltage power supply
- One high voltage power supply for the polarization of the detector
- One sequencer, called « Altera box », supplying all the signals needed for the smooth functioning of the preamps-shaper
- A 14 Mbq Strontium source
- A trigger based on a scintillator signal above some threshold
- One PC with
 - an ADC card for proper reading of the analog signals from the detector
 - LabView installed, for data taking and coordination of the all test bench
- One other PC with a dedicated ROOT analysis software

Electronics

Amplifiers-shapers

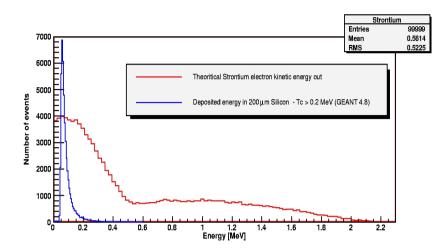


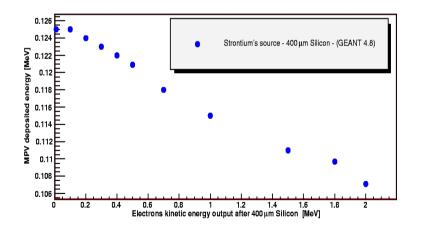
Sequencer and low voltage supplies



4 VA1-CMS





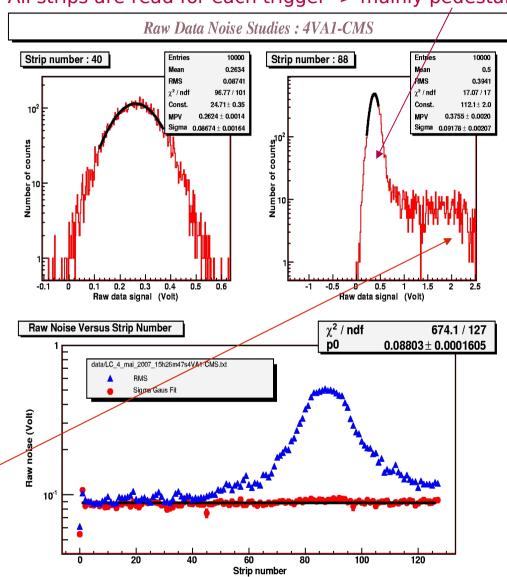


Raw data = noise + common mode +pedestal + physical signal

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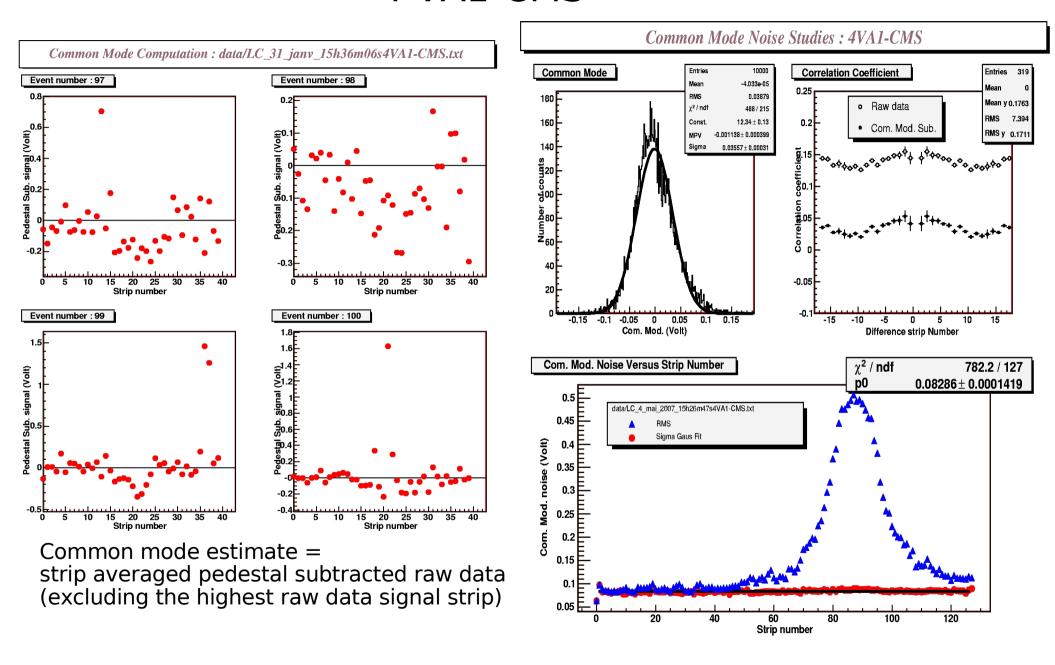
Pedestal estimate = gaussian fitted mean

All strips are read for each trigger -> mainly pedestals



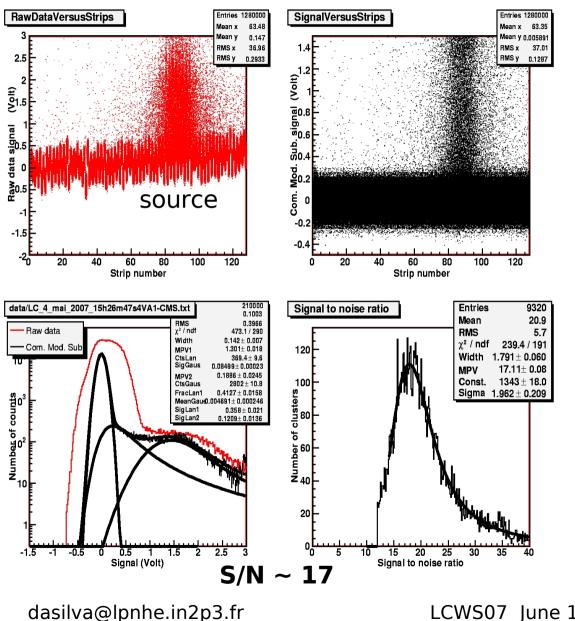
Raw data noise estimate = gaussian fitted sigma LCWS07 June 1 6

4 VA1-CMS

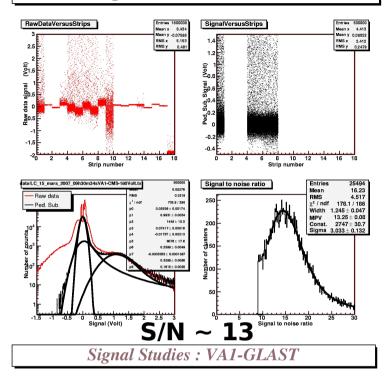


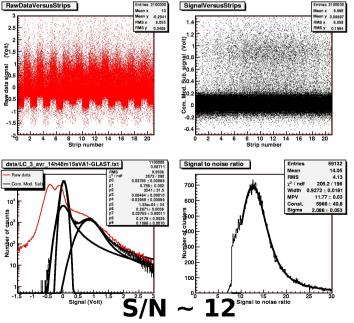
Preliminary results

Signal Studies: 4VA1-CMS



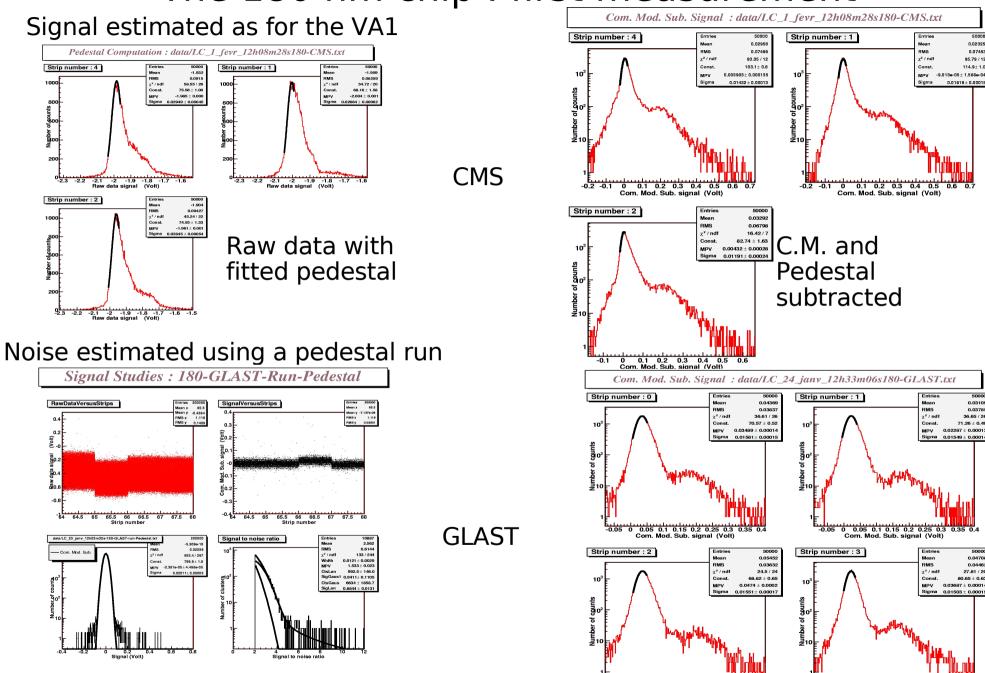
Signal Studies: VA1-CMS





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The 180 nm chip: first measurement

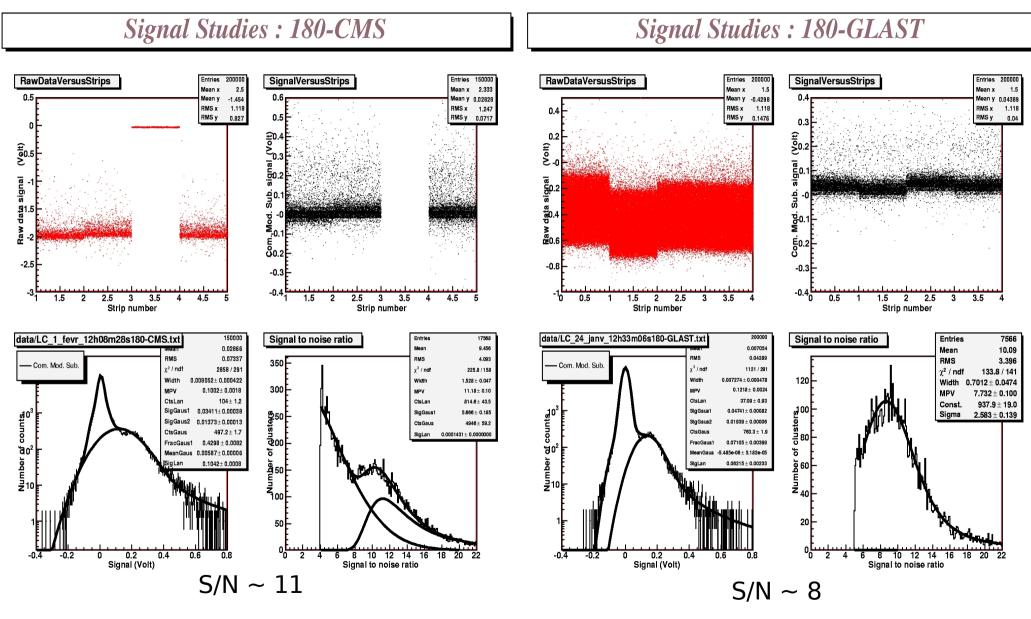


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0.1 0.2 0.3 Com. Mod. Sub. signal (Volt)

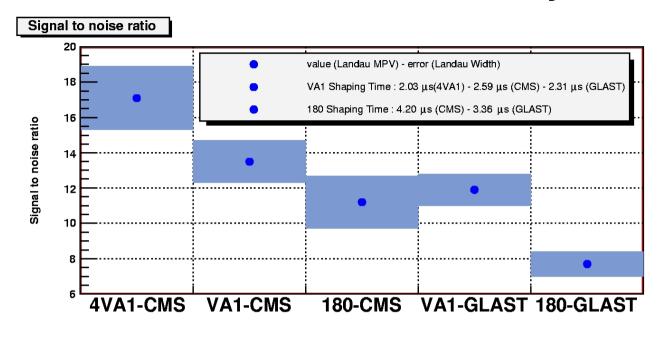
180 nm: the first preliminary results

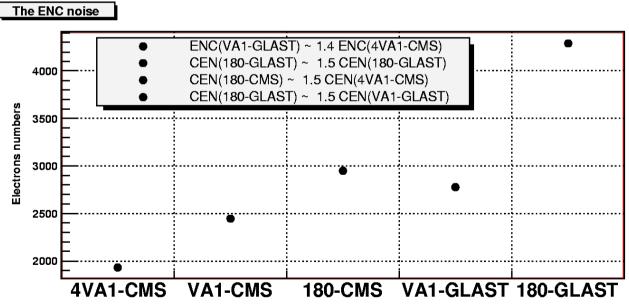


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S/N and Noise Summary





Conclusions and outlook

